



00862.022434.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Shinichi SHIMA )  
Application No.: 09/986,958 )  
Filed: November 13, 2001 )  
For: EXPOSURE APPARATUS, METHOD OF )  
MANUFACTURING SEMICONDUCTOR )  
DEVICES, SEMICONDUCTOR MANUFAC- )  
TURING PLANT, METHOD OF MAINTAIN- )  
ING EXPOSURE APPARATUS, AND POSITION )  
DETECTOR )

Examiner: H. Nguyen  
Group Art Unit: 2851  
April 24, 2003

#6/a  
4/30/03  
am  
(entered  
in part)

The Commissioner for Patents  
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Official Action dated January 24, 2003, please amend the above-identified application as follows:

INTRODUCTORY COMMENTS

This Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice dated February 4, 2003, and entitled "Amendments in a Revised Format Now Permitted."